



*Drayc*  
*AF*  
*1763*

520.39737X00

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): T. OTSUBO

Serial No.: 09/842,000

Filed: April 26, 2001

For: PLASMA PROCESSING APPARATUS AND PROCESSING  
METHOD

Group: 1763

Examiner: A. Crowell

**AMENDMENT AFTER FINAL ACTION**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

March 9, 2004

Sir:

In response to the Office Action dated December 9, 2003, the following amendments and remarks are respectfully submitted in connection with the above-identified application, as listed below and as set forth on the following pages:

Amendments to the Claims; and

Remarks are included following the amendments.